

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	09/447,378	NISHIKAWA ET AL.
	Examiner Mike Qi	Art Unit 2871

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
349	110 3c 125 33 129	05-PC-LH 4/12/06	ZAC	